

DOCKET NO: 264741US-2 PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
AKIRA AKASAKA, ET AL. : EXAMINER: ELVE, MARIA A.
SERIAL NO: 10/523,392 :
FILED: FEBRUARY 3, 2005 : GROUP ART UNIT: 3742
FOR: LASER PROCESSING :
APPARATUS, PROCESSING METHOD
AND METHOD FOR MANUFACTURING
CIRCUIT BOARD USING SAME

RESPONSE

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action of May 19, 2008, favorable reconsideration of this application, in view of the present response, is respectfully requested.

Remarks begin on page 2 of this paper.